

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Application of:

Kazunari SEKIGAWA, et al.

Serial No. 10/809,372

Group Art Unit: 1756

Confirmation No. 7624

Filed: March 26, 2004

Examiner: YOUNG, CHRISTOPHER G

For: EXPOSING APPARATUS AND EXPOSING METHOD, FOR MASKLESS EXPOSURE  
OF SUBSTRATE TO BE EXPOSED, AND PLOTTER AND PLOTTING METHOD FOR  
DIRECTLY PLOTTING ON OBJECT TO BE PLOTTED

**RESPONSE TO RESTRICTION REQUIREMENT**

Commissioner for Patents  
PO Box 1450  
Alexandria, VA 22313-1450

Sir:

This is in response to the Office Action mailed May 31, 2007, and having a period for response set to expire on June 30, 2007.

The following amendments and remarks are respectfully submitted. Reconsideration of the claims is respectfully requested.